

<b>Notice of References Cited</b>	Application/Control No. 10/532,952	Applicant(s)/Patent Under Reexamination ANEGAWA ET AL.	
	Examiner JEONG S. PARK	Art Unit 2454	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,807,388	10-2004	Kojima et al.	399/80
*	B	US-2003/0107771	06-2003	Shibata, Koichi	358/3.28
*	C	US-2003/0154395	08-2003	Miura et al.	713/200
	D	US-			
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	F	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

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	N					
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**NON-PATENT DOCUMENTS**

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